



2834
PATENT
930055-2031

DW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Tetsuo YAMADA, Kosuke NISHIMURA, Keigo NAGAO
Serial No. : 10/518,704
For : THIN FILM PIEZOELECTRIC OSCILLATOR, THIN
FILM PIEZOELECTRIC DEVICE, AND
MANUFACTURING METHOD THEREOF
Filing Date : December 17, 2004
Examiner : Not Yet Assigned
Group Art Unit : 2834

745 Fifth Avenue
New York, NY 10151

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Ronald R. Santucci, Reg. No. 28,988

Name of Applicant, Assignee or Registered Representative

Ronald R. Santucci
Signature

August 1, 2005

Date of Signature

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97(B)

Commissioner for Patents
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Dear Sir:

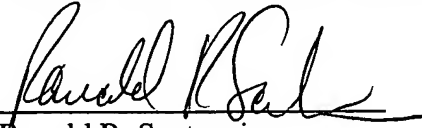
The Information Disclosure Statement submitted herewith is being filed within
three months of the filing of a national application; within three months of the date of entry of
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mailing date of a first Office Action on the merits, whichever event occurs last. No fee is required.

The Commissioner is authorized to charge any additional fee that may be required to Deposit Account No. 50-0320.

Respectfully submitted,
FROMMER LAWRENCE & HAUG LLP

By:


Ronald R. Santucci
Reg. No. 28,988
(212) 588-0800



Based on Form PTO-147 (3/90) LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)	ATTY. DOCKET NO. 930055-2031	SERIAL NO. 10/518,704
	APPLICANT Tetsuo YAMADA et al.	
	FILING DATE December 17, 2004	GROUP 2834

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AF	JP 58-153412 A	09/12/1983	Japan (English translation of Abstract)			X (of Abstract)	
	AG	JP 58-156220 A	09/17/1983	Japan (English translation of Abstract)			X (of Abstract)	
	AH	JP 60-142607 A	07/27/1985	Japan (English translation of Abstract)			X (of Abstract)	
	AI	JP 02-313109 A	01/17/1990	Japan (English translation of Abstract)			X (of Abstract)	
	AJ	JP 2000-069594 A	03/03/2000	Japan (English translation of Abstract)			X (of Abstract)	
	AK	JP 2000-307376 A	11/02/2000	Japan (English translation of Abstract)			X (of Abstract)	
	AL	JP 2000-332568 A	11/30/2000	Japan (English translation of Abstract)			X (of Abstract)	
	AM	JP 2001-203558 A	07/27/2001	Japan (English translation of Abstract)			X (of Abstract)	
	AN	JP 2001-345656 A	12/14/2001	Japan (English translation of Abstract)			X (of Abstract)	
	AO	JP 2002-076823 A	03/15/2002	Japan (English translation of Abstract)			X (of Abstract)	
	AP	JP 2002-353760 A	12/06/2002	Japan (English translation of Abstract)			X (of Abstract)	
	AQ	JP 2003-133892 A	05/09/2003	Japan (English translation of Abstract)			X (of Abstract)	

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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